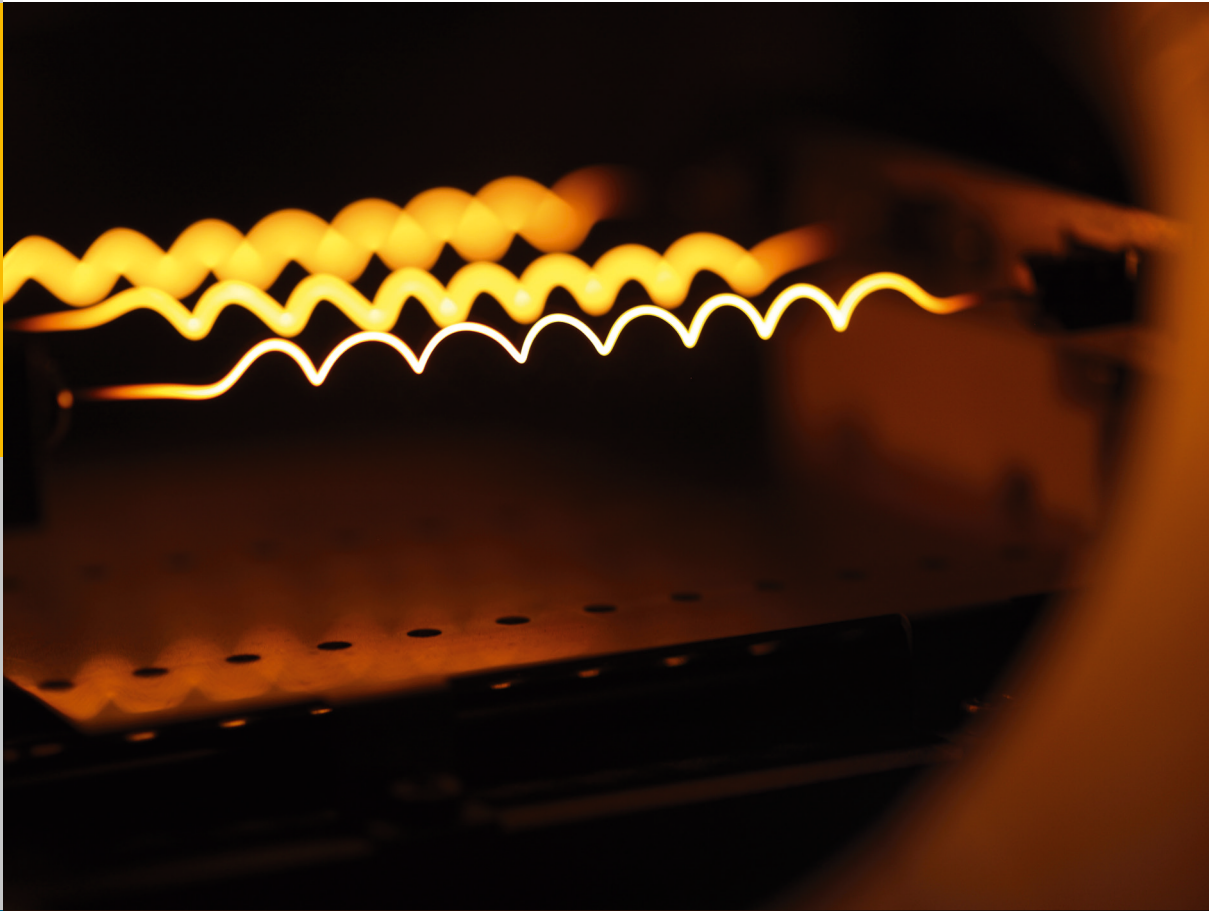


Microcrystalline Silicon Carbide for Silicon Heterojunction Solar Cells

Manuel Bernhard Pomaska



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